

Docket No.: TCP-005



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shojiro KOMATSU et al : Confirmation No. 7653

U.S. Patent Application No. 10/569,545 : Group Art Unit: 4152

Filed: February 27, 2006 : Examiner: Vera KATZ

For: **FILM OF SP3-BONDED BORON NITRIDE HAVING A SELF-ORGANIZED SURFACE TEXTURE CAPABLE OF PROMOTING FIELD ELECTRON EMISSION, METHOD FOR PRODUCING THE SAME AND USE THEREOF**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO THE RESTRICTION REQUIREMENT

Sir:

In response to the restriction requirement of September 9, 2008, the applicant elects Group II, claims 6 to 10, drawn to a method of manufacture of boron nitride membrane body. Please examine the application.

Respectfully submitted,

KANESAKA BERNER & PARTNERS

A handwritten signature in black ink, appearing to read "Manabu Kanesaka".

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